

Application/Control No.	. Applicant(s)/Patent under Reexamination	
10/582,158	KAMIYAMA ET AL.	
Examiner	Art Unit	
Noah Kamen	3747	

	SEARCHED		
Class	Subclass	Date	Examiner
123	48R	4/4/2007	K
	48C		
	78R		
	78C		

INT	INTERFERENCE SEARCHED		
Class	Subclass	Date	Examiner

SEARCH NOTES (INCLUDING SEARCH STRATEGY)			)
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EAST		4/4/2007	W
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